# Freescale Semiconductor Technical Data

# 200 kPa On-Chip Temperature Compensated & Calibrated Pressure Sensors

The MPX2200 series device is a silicon piezoresistive pressure sensor providing a highly accurate and linear voltage output - directly proportional to the applied pressure. The sensor is a single monolithic silicon diaphragm with the strain gauge and a thin-film resistor network integrated on-chip. The chip is laser trimmed for precise span and offset calibration and temperature compensation. They are designed for use in applications such as pump/motor controllers, robotics, level indicators, medical diagnostics, pressure switching, barometers, altimeters, etc.

#### Features

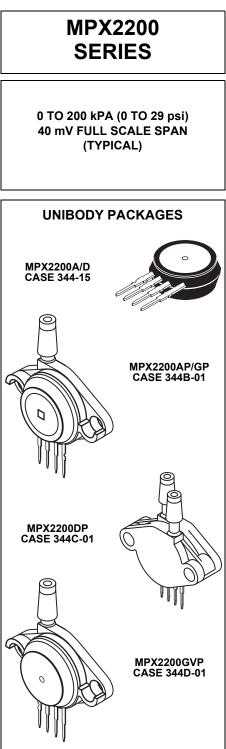
- Temperature Compensated Over 0°C to +85°C
- ±0.25% Linearity (MPX2200D)
- Easy-to-Use Chip Carrier Package Options
- · Available in Absolute, Differential and Gauge Configurations

### **Typical Applications**

- Pump/Motor Controllers
- Robotics
- Level Indicators
- Medical Diagnostics
- Pressure Switching
- Barometers
- Altimeters

	ORDERING INFORMATION <sup>(1)</sup>			
Device Type	Options	Case No.	MPX Series Order Number	Device Marking
Basic Element	Absolute, Differential	344	MPX2200A MPX2200D	MPX2200A MPX2200D
Ported Elements	Differential	344C	MPX2200DP	MPX2200DP
	Absolute, Gauge	344B	MPX2200AP MPX2200GP	MPX2200AP MPX2200GP
	Gauge, Vacuum	344D	MPX2200GVP	MPX2200GVP

1. MPX2200 series pressure sensors are available in absolute, differential and gauge configurations. Devices are available in the basic element package or with pressure port fittings which provide printed circuit board mounting ease and barbed hose pressure connections.

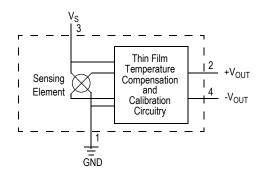


PIN NUMBER			
1	GND <sup>1</sup>	3	V <sub>S</sub>
2 +V <sub>OUT</sub> 4 -V <sub>OUT</sub>			
1. Din 1 in noted by the noteb in the load			

1. Pin 1 in noted by the notch in the lead.



MPX2200



#### Figure 1. Temperature Compensation Pressure Sensor Schematic

## **VOLTAGE OUTPUT VS. APPLIED DIFFERENTIAL PRESSURE**

The differential voltage output of the sensor is directly proportional to the differential pressure applied.

The absolute sensor has a built-in reference vacuum. The output voltage will decrease as vacuum, relative to ambient, is drawn on the pressure (P1) side.

The output voltage of the differential or gauge sensor increases with increasing pressure applied to the pressure (P1) side relative to the vacuum (P2) side. Similarly, output voltage increases as increasing vacuum is applied to the vacuum (P2) side relative to the pressure (P1) side.

Figure 1 illustrates a block diagram of the internal circuitry on the stand-alone pressure sensor chip.

## Table 1. Maximum Ratings<sup>(1)</sup>

Rating	Symbol	Value	Unit
Maximum Pressure (P1 > P2)	P <sub>MAX</sub>	800	kPa
Storage Temperature	T <sub>STG</sub>	-40 to +125	°C
Operating Temperature	T <sub>A</sub>	-40 to +125	°C

1. Exposure beyond the specified limits may cause permanent damage or degradation to the device.

Characteristic	Symbol	Min	Тур	Max	Units
Differential Pressure Range <sup>(1)</sup>	P <sub>OP</sub>	0	—	200	kPa
Supply Voltage <sup>(2)</sup>	V <sub>S</sub>	—	10	16	V <sub>DC</sub>
Supply Current	۱ <sub>0</sub>	—	6.0	—	mAdc
Full Scale Span <sup>(3)</sup>	V <sub>FSS</sub>	38.5	40	41.5	mV
Offset <sup>(4)</sup>	V <sub>OFF</sub>	-1.0	—	1.0	mV
Sensitivity	$\Delta V / \Delta P$	—	0.2	—	mV/kPa
Linearity <sup>(5)</sup> MPX2200D Series MPX2200A Series	-	-0.25 -1.0	—	0.25 1.0	%V <sub>FSSI</sub>
Pressure Hysteresis <sup>(5)</sup> (0 to 200 kPa)	—	—	±0.1	—	%V <sub>FSS</sub>
Temperature Hysteresis <sup>(5)</sup> (- 40°C to +125°C)	_	—	±0.5	—	%V <sub>FSS</sub>
Temperature Coefficient of Full Scale Span <sup>(5)</sup>	TCV <sub>FSS</sub>	-1.0	_	1.0	%V <sub>FSS</sub>
Temperature Coefficient of Offset <sup>(5)</sup>	TCV <sub>OFF</sub>	-1.0	—	1.0	mV
Input Impedance	Z <sub>IN</sub>	1300	—	2500	W
Output Impedance	Z <sub>OUT</sub>	1400	—	3000	W
Response Time <sup>(6)</sup> (10% to 90%)	t <sub>R</sub>	—	1.0	—	ms
Warm-Up Time	—	—	20	—	ms
Offset Stability <sup>(7)</sup>	_	—	±0.5	—	%V <sub>FSS</sub>

Table 2. Operating Characteristics (V<sub>S</sub> = 10 V<sub>DC</sub>, T<sub>A</sub> = 25°C unless otherwise noted, P1 > P2)

1. 1.0 kPa (kiloPascal) equals 0.145 psi.

2. Device is ratiometric within this specified excitation range. Operating the device above the specified excitation range may induce additional error due to device self-heating.

- 3. Full Scale Span (V<sub>FSS</sub>) is defined as the algebraic difference between the output voltage at full rated pressure and the output voltage at the minimum related pressure.
- 4. Offset (V<sub>OFF</sub>) is defined as the output voltage at the minimum rated pressure.
- 5. Accuracy (error budget) consists of the following:
  - Linearity: Output deviation from a straight line relationship with pressure, using end point method, over the specified pressure range.
  - Temperature Hysteresis:Output deviation at any temperature within the operating temperature range, after the temperature is cycled to and from the minimum or maximum operating temperature points, with zero differential pressure applied.
  - Pressure Hysteresis: Output deviation at any pressure with the specified range, when this pressure is cycled to and from the minimum or maximum rated pressure at 25°C.
  - TcSpan: Output deviation at full rated pressure over the temperature range of 0 to 85°C, relative to 25°C.
  - TcOffset: Output deviation with minimum rated pressure applied, over the temperature range of 0 to 85°C, relative to 25°C.
- 6. Response Time is defined as the time form the incremental change in the output to go from 10% to 90% of its final value when subjected to a specified step change in pressure.
- 7. Offset stability is the product's output deviation when subjected to 1000 hours of Pulsed Pressure, Temperature Cycling with Bias Test.

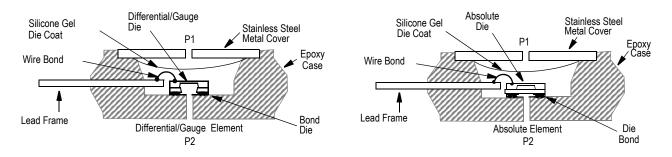


Figure 4. Cross Sectional Diagrams (Not to Scale)

Figure 4 illustrates an absolute sensing die (right) and the differential or gauge die in the basic chip carrier (Case 344). A silicone gel isolates the die surface and wire bonds from the environment, while allowing the pressure signal to be transmitted to the silicon diaphragm.

The MPX2200 series pressure sensor operating characteristics and internal reliability and qualification tests are based on use of dry air as the pressure media. Media other than dry air may have adverse effects on sensor performance and long term reliability. Contact the factory for information regarding media compatibility in your application.

# PRESSURE (P1)/VACUUM (P2) SIDE IDENTIFICATION TABLE

Freescale designates the two sides of the pressure sensor as the Pressure (P1) side and the Vacuum (P2) side. The Pressure (P1) side is the side containing the silicone gel which isolates the die from the environment. The differential

or gauge sensor is designed to operate with positive differential pressure applied, P1 > P2. The absolute sensor is designed for vacuum applied to P1 side.

The Pressure (P1) side may be identified by using Figure 3.

#### Table 3. Pressure (P1) Side Delineation

Part Number	Case Type	Pressure (P1) Side Identifier
MPX2200A/D	344	Stainless Steep Cap
MPX2200DP	344C	Side with Part Marking
MPX2200AP/GP	344B	Side with Port Attached
MPX2200GVP	344D	Stainless Steep Cap